



#11/BH
7/22/03

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2813

Entered
8/19/03
Mullish

00862.022224.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Toshiyuki SHIGARAKI

Application No.: 09/851,158

Filed: May 9, 2001

For: SEMICONDUCTOR MANUFACTURING
APPARATUS AND METHOD OF
MANUFACTURING SEMICONDUCTOR
DEVICES

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Examiner: E. Kielen

Group Art Unit: 2813

July 15, 2003

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JUL 18 2003
10 2800 MAIL ROOM

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL REJECTION
AND REQUEST FOR WITHDRAWAL OF FINALITY THEREOF**

Sir:

Please amend the above-identified application as follows in response to the Official

Action dated April 15, 2003:

DO NOT ENTER 7/22/03 EK

INTRODUCTORY COMMENTS

This Amendment has been prepared in accordance with the Revised Format established by the U.S. Patent and Trademark Office, as permitted in the Pre-OG Notice dated February 4, 2003, and entitled “Amendments in a Revised Format Now Permitted.”